



MS PETITION  
PATENT  
4659-0101P

IN THE U.S. PATENT AND TRADEMARK OFFICE

Patentee: DNS KOREA CO., LTD.  
Patent No.: 6,089,763  
Issue Date: July 18, 2000  
For: SEMICONDUCTOR WAFER PROCESSING SYSTEM

**PETITION TO PRINT DUPLICATE LETTERS PATENT**

**MS PETITION**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

November 2, 2004

Sir:

This is a Petition requesting that a duplicate copy of U.S. Letters Patent No. 6,089,763 be prepared and mailed to the undersigned, as the original Letters Patent No. 6,089,763.

Accordingly, as the original Letters Patent No. 6,089,763 is lost and cannot be retrieved, it is requested that a duplicate copy of Letters Patent No. 6,089,763 be prepared and forwarded to the undersigned.

Should any outstanding matters remain in the above-identified application, please contact the undersigned at (703) 205-8000 in the Washington, DC area.

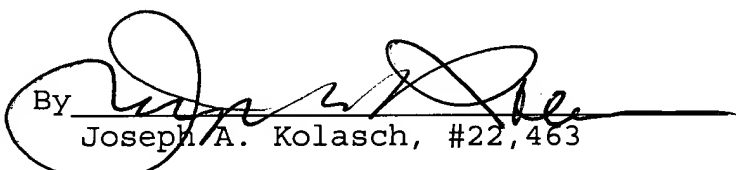
A check in the amount of \$130.00 is attached herewith, as payment of the appropriate fees under 37 C.F.R. § 1.17(h).

If necessary, the Commissioner is hereby authorized in this, concurrent, and future replies, to charge payment or credit any overpayment to Deposit Account No. 02-2448 for any additional fee required under 37 C.F.R. §§ 1.16 or 1.17; particularly, extension of time fees.

Respectfully submitted,

BIRCH, STEWART, KOLASCH & BIRCH, LLP

By

  
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Attachment(s)